



Article

# Study and Characterization of Silicon Nitride Optical Waveguide Coupling with a Quartz Tuning Fork for the Development of Integrated Sensing Platforms

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### Highlights

# What are the main findings?

- We successfully coupled a silicon nitride waveguide with a custom-designed, low-frequency, and T-shaped QTF, enabling both Quartz-Enhanced Photoacoustic Spectroscopy (QEPAS) and Light-Induced Thermoelastic Spectroscopy (LITES) techniques for sensing.
- We achieved comparable signal-to-noise ratios with QEPAS and LITES when detecting 1.6% water vapor concentration, with performance limited by the output power illuminating the QTF.

#### What is the implication of the main finding?

- Demonstrated the feasibility of integrating photonic components with piezoelectric resonators for portable gas-sensing applications.
- Identified on-chip laser-waveguide integration as a key route to compact sensing platforms.

Abstract: This work demonstrates an ultra-compact optical gas-sensing system, consisting of a pigtailed laser diode emitting at 1392.5 nm for water vapor (H<sub>2</sub>O) detection, a silicon nitride (Si<sub>3</sub>N<sub>4</sub>) optical waveguide to guide the laser light, and a custom-designed, low-frequency, and T-shaped Quartz Tuning Fork (QTF) as the sensitive element. The system employs both Quartz-Enhanced Photoacoustic Spectroscopy (QEPAS) and Light-Induced Thermoelastic Spectroscopy (LITES) techniques for trace gas sensing. A 3.8 mm-wide, S-shaped waveguide path was designed to prevent scattered laser light from directly illuminating the QTF. Both QEPAS and LITES demonstrated comparably low signal-tonoise ratios (SNRs), ranging from 1.6 to 3.2 for a 1.6% indoor H<sub>2</sub>O concentration, primarily owing to the reduced optical power (~300  $\mu$ W) delivered to the QTF excitation point. These results demonstrate the feasibility of integrating photonic devices and piezoelectric components into portable gas-sensing systems for challenging environments.



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**Keywords:** LITES; optical gas sensing; photonic integration; piezoelectric resonator; QEPAS; quartz tuning fork; silicon nitride waveguide

### 1. Introduction

Gas-sensing technologies play a vital role across diverse fields, ranging from environmental monitoring and industrial process control to medical diagnostics and security applications [1–7]. The growing demand for compact, reliable, and highly sensitive detection systems has driven intensive research toward the miniaturization and integration of sensing components [8–11]. However, traditional approaches, such as conventional spectroscopic methods and electrochemical sensors, rely on bulky equipment or complex free-space optical setups that limit their deployment in real-world, challenging environments [12–15].

In recent years, optical gas-sensing techniques have proven their advantages in terms of selectivity, response time, and immunity to electromagnetic interference [16–20]. Among these, approaches implementing Quartz Tuning Forks (QTFs) as sensitive elements have gained a significant role in the development of in situ and real-time gas sensors, offering concrete potential for reducing the overall system footprint and enabling large deployment while preserving high reliability. Among the QTF-based approaches, Quartz-Enhanced Photoacoustic Spectroscopy (QEPAS) is the most established technique [19,21,22], relying on the photoacoustic effect, i.e., the generation of acoustic waves by the target gas molecules absorbing modulated laser light and relaxing energy via non-radiative processes [23]. QTFs in QEPAS are employed as sharply resonant acoustic transducers, offering high sensitivity while maintaining a compact system footprint [24–28]. Indeed, this technique demonstrates detection limits in the few parts-per-billion (ppb) range for various gases, down to parts per trillion (ppt) in certain cases, while requiring minimal sample volumes [22,29–32].

Another approach is Light-Induced Thermoelastic Spectroscopy (LITES), which employs QTFs as photodetectors for gas sensing, exploiting a typical Tunable Diode Laser Absorption Spectroscopy (TDLAS) configuration [33–36]. The light transmitted through an absorbing gas sample is directly focused onto the surface of the QTF and the portion of optical power released within the resonator generates deformation due to thermoelastic conversion [37]. Thus, a modulation of the residual light beam interacting with the QTF causes periodic heating/cooling, inducing a strain field, which in turn generates a modulation of polarization charges on the tuning fork's surface, due to quartz piezoelectricity [38]. This second embodiment of QTFs as sensitive elements has demonstrated detection performances comparable to, or even higher than, those of commercially available photoconductive/photovoltaic detectors, and a high and flat spectral responsivity in the 1–10  $\mu$ m wavelength range [39–43].

For sensing applications, the field of integrated photonics has simultaneously undergone rapid advancement, with Silicon Nitride-On-Insulator (SiNOI) emerging as a promising platform for Near-InfraRed (NIR) applications [44–47], since it offers a broad transparency window extending from 400 nm to 8  $\mu$ m and enables applications across a wide spectral range [48,49]. The Si<sub>3</sub>N<sub>4</sub>-based waveguides achieve remarkably low propagation losses, crucial for sensing applications [50–53], and the high refractive index contrast of silicon nitride facilitates the fabrication of compact device footprints, with efficient light confinement [54]. Furthermore, its CMOS compatibility ensures scalable manufacturing potential, while excellent thermal stability guarantees a reliable operation across varying environmental conditions [55–57]. These properties collectively make Si<sub>3</sub>N<sub>4</sub> particularly suitable for gas-sensing applications, where stable and efficient light delivery is

crucial [58,59], creating the potential for building optical systems without the use of discrete optical components, such as lenses, mirrors, and so on.

Nevertheless, significant challenges remain in integrating onto a single chip the fundamental components required for optical gas sensing, i.e., laser source, light/molecule interaction volume, and detector [60]. In this context, optical coupling efficiency remains the most critical parameter, often limiting overall system sensitivity [61,62]. Several studies have explored strategies to integrate the optical sources on various platforms [63] and to design optimized waveguides to enhance light–gas interaction [64]. Considering possible detectors for integrated optical sensing [65], QTFs and Lithium Niobate Tuning Fork (LiNTF) [66] offer high versatility, compact size, and excellent gas-sensing performance, making them promising candidates for integration.

To the best of our knowledge, no previous work has reported a fully or semi-integrated photonic sensing system exploiting on-chip waveguides with such a piezoelectric resonator. The existing literature describes only free-space optical coupling to QTFs [67], all-fiber configurations [68], or 3D-printed acoustic modules [69] but no on-chip waveguide coupling to piezoelectric resonators. While there are reports of integrated photonic gas sensors, these use different detection mechanisms, such as evanescent field absorption or refractive index changes [70], not piezoelectric transduction.

The closest related work, by De Carlo et al., described the modeling and design of a QEPAS sensor in which the laser source and the beam-delivery optics were bonded together and semi-integrated with the QTF [71]. In that configuration, an integrated waveguide couples the laser output to an optical ring resonator located between the QTF prongs, while a pair of mechanical resonators confines and enhances the acoustic standing waves generated by the modulated evanescent optical field. This configuration produced an acoustic wavefront with a pressure comparable to that achieved in free space, on-beam QEPAS. However, the full integration of photonic components with QTFs has yet to be experimentally verified.

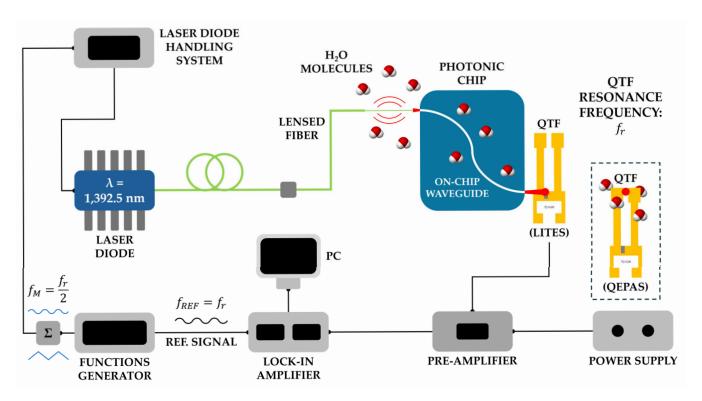
In this paper, we demonstrate a novel semi-integrated sensing architecture for QEPAS and LITES that pairs a  $\rm Si_3N_4$  optical waveguide with a custom-designed, low-frequency, and T-shaped QTF acting as the detector. The resulting 3.8 mm-wide, S-shaped waveguide path effectively mitigates interference from scattered light, a common issue in integrated sensing platforms [72]. In this proof of concept, we detected water vapor by targeting the absorption line at 7181.16 cm<sup>-1</sup> [73]. The photonic–piezoelectric components' integration, along with the use of fiber-based laser beam delivery methods, is a key factor in offering a compact, rugged, and portable sensing system. This development process will also pave the way for the deployment of fully integrated sensors on drones, to empower and push real-time monitoring in dangerous and harsh environments [74,75].

# 2. Semi-Integrated Sensing Architecture

Figure 1 presents a schematic of the experimental setup used to perform both QEPAS and LITES measurements.

The experimental setup includes three main components: a laser diode, a  $\rm Si_3N_4$  waveguide, and a custom-designed QTF. The optical source is a tunable, single-mode, and pigtailed laser diode (model EP1392-DM-B01-FM, Eblana Photonics Ltd., Dublin, Ireland), emitting at a central wavelength ( $\lambda$ ) of 1392.5 nm resonant with the NIR H<sub>2</sub>O absorption feature at 7181.16 cm<sup>-1</sup> [73]. The laser output was coupled to a tapered lensed fiber (from Highpak Solutions, Suffolk, UK), yielding a focused beam with a spot size of approximately 2.5  $\mu$ m. The measured laser optical power available at the lensed fiber output to be coupled into the waveguide input was approximately 4 mW.

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**Figure 1.** Schematic of the experimental setup for QEPAS and LITES measurements. The QTF position relative to the laser beam spot from the waveguide output port (red dot) differentiates between LITES and QEPAS configurations (dashed box).

A thermally oxidized silicon wafer with a deposited layer of plasma-enhanced chemical vapor deposition  $\mathrm{Si_3N_4}$  (300 nm thick) was utilized. The desired optical waveguides layout was then defined on the resist using electron beam lithography. Subsequently, the patterns were transferred to the  $\mathrm{Si_3N_4}$  layer through an inductively coupled plasma etching process. The cross-section of the waveguide is shown in Figure 2.

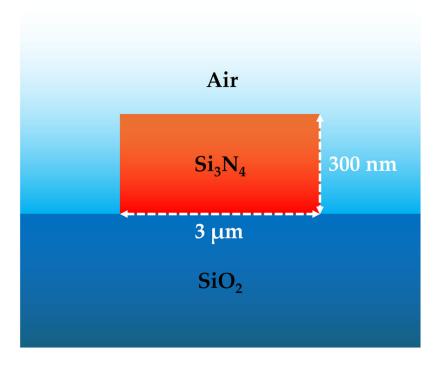
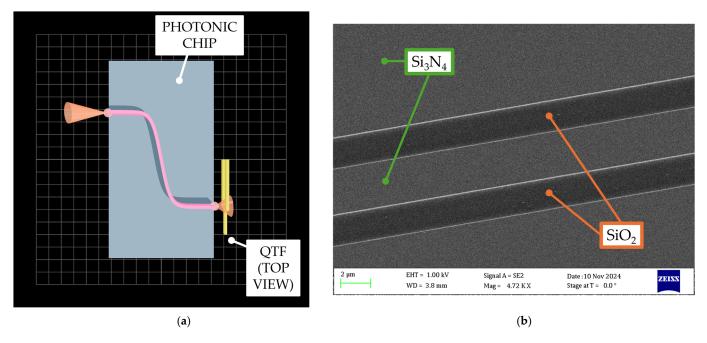


Figure 2. Cross-sectional schematic of the air-clad Si<sub>3</sub>N<sub>4</sub> optical waveguide structure.

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The strip waveguide consists of a  $Si_3N_4$  ( $n_{Si3N4} = 2 @\lambda$ ) core region with a rectangular cross-section, 3  $\mu$ m in width and 300 nm in height, deposited on a substrate composed of 2  $\mu$ m-thick silica ( $n_{SiO2} = 1.45 @\lambda$ ) [54] over a 525  $\mu$ m-thick silicon carrier wafer. For LITES detection, the air cladding around the waveguide core along with the polished region of the optical lensed fiber termination provides an absorption path for a direct interaction between the evanescent field and the surrounding gas. Figure 3a,b show more details of the photonic chip.



**Figure 3.** Waveguide details. (a) Not-to-scale 3D rendering of the on-chip waveguide topology and (b) SEM image of the  $Si_3N_4$  waveguide geometry at  $4720\times$  magnification (green arrows indicate  $Si_3N_4$  layer; orange arrows indicate  $Si_2N_4$  layer; orange  $Si_2N_4$ 

The overall chip dimensions are 15 mm  $\times$  8 mm, and the waveguide has an approximate path length of 9.4 mm, with an input/output offset by 3.8 mm through an S-shaped path designed in the middle section, as shown in Figure 3a. The S-shaped geometry serves both to prevent scattered light from directly illuminating the 1.2 mm-wide QTF side prong [29] and to provide adequate space for potential integrated laser direct bonding to the chip [76]. Figure 3b shows a SEM image taken at  $4720 \times$  magnification of the waveguide geometry, clearly resolving the silicon nitride waveguide and adjacent silica layer.

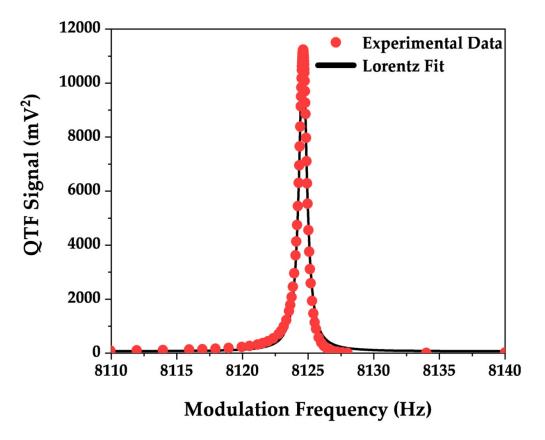
The SiNOI platform was chosen for its advantageous optical properties in the tuning range selected for water vapor detection [48], including the propagation loss as low as <0.5 dB/cm potentially achievable using low-temperature fabrication processes directly from foundries [77].

The input laser optical power was  $P_{IN}\approx 4$  mW and the measured output power illuminating the QTF is approximately  $P_{OUT}\approx 300~\mu W$ . Instead, by considering only the propagation losses of the employed SiNOI platform (i.e., ~4 dB/cm [78]) and the reflectivity between the air–Si<sub>3</sub>N<sub>4</sub> interfaces (i.e., ~11.11% [54]), the estimated output power should be  $P_{EST}\approx 1.35$  mW. The discrepancy between these two values (i.e., a factor of ~4.5) can be attributed to sources such as (i) difficulties in effectively coupling the laser light to the input port of the waveguide, which involves resizing the lensed optical fiber mode to match the waveguide one; (ii) imperfections in the fabrication process; (iii) as well as parasitic reflections within the waveguide structure caused by cleaved facets. The observed laser power discrepancy of ~6.53 dB between  $P_{EST}$  and  $P_{OUT}$  can be attributed primarily to mode

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field diameter mismatch and coupling interface losses, common in fiber-to-waveguide photonic systems and capable of reaching values as high as 4 dB/facet, as reported in the literature [79]. By using techniques such as mode adaptors and spot size converters, the optical power illuminating the QTF can be substantially increased [80,81]. The resonance properties of the T-shaped, grooved QTF (model T2-G08 [29]) were retrieved through an electrical characterization of the resonator.

Figure 4 shows the electrical response of the QTF (expressed in  $mV^2$ ), measured at atmospheric pressure, as a function of the modulation frequency.

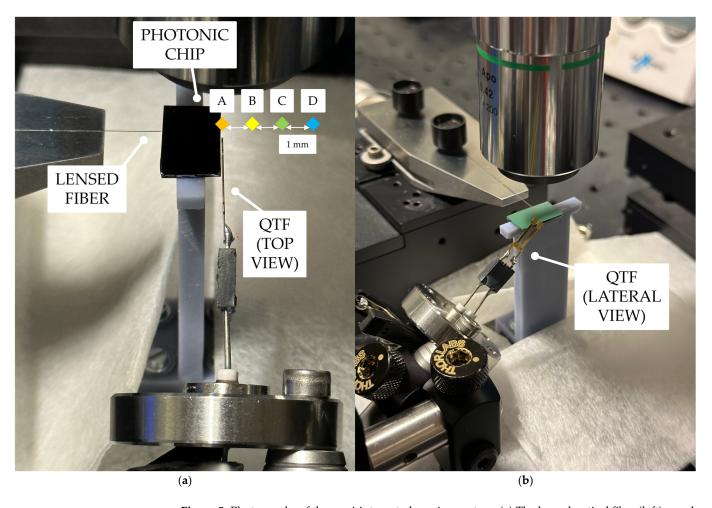


**Figure 4.** Electrical characterization of the QTF measured under atmospheric pressure. Red dots: experimental data; black line: Lorentzian fit.

The resonance curve shown in Figure 4, fitted with a Lorentzian function, returned a fundamental mode resonance frequency ( $f_r$ ) of 8124.61 Hz and a quality factor (Q) of more than 11,000.

The QTF and the photonic chip must be positioned close to each other: owing to the high divergence of the laser beam at the waveguide output, stray light can hit the gold electrodes on the QTF surface, leading to a high noise generation [82]. Since the resonance properties could be affected by the presence of the chip in proximity to the QTF surface [83],  $f_r$  and Q were monitored at different distances between the resonator and the waveguide. Starting from the closest position, i.e., a few tens-of-microns distance, shown in Figure 5a (namely Position A), achieved with the help of a camera and a  $20 \times$  magnification objective, the QTF was moved away with 1 mm increments to three additional positions (namely Positions B, C, and D), all indicated in Figure 5a, with the help of a translational stage. Moreover, Figure 5b shows a lateral view of the same subject.

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**Figure 5.** Photographs of the semi-integrated sensing system. (a) The lensed optical fiber (left) couples laser light into the on-chip waveguide (center), while the QTF (right) serves as the detector; (b) lateral view of the same semi-integrated sensing system.

No changes in  $f_r$  or Q were measured at any of the four QTF positions investigated, confirming that the presence of the photonic chip does not affect the QTF resonance properties.

The laser beam was aligned to the on-chip waveguide input port using both a three-axis translation stage (MBT602/M, Thorlabs GmbH, Bergkirchen, Germany)—equipped with a tapered V-groove fiber holder (HFV002, Thorlabs GmbH)—and a Short-Wavelength IR (SWIR) camera (MicronViewer 7290, Electrophysics Corp., Fairfield, NJ, USA) with a  $20\times$  objective (MY20X-824, Thorlabs GmbH). The position of the QTF with respect to the laser beam exiting the waveguide output differs between QEPAS and LITES configurations, as shown in the dashed box in Figure 1. Precise positioning of the QTF was achieved using a second three-axis translation stage while monitoring the alignment through the same SWIR camera. All measurements for QEPAS and LITES were repeated at the four abovementioned QTF distances, at room temperature and under atmospheric pressure (760 Torr) in a humidity-controlled environment. The laser diode temperature and the injected current were controlled using the Laser Diode Handling System (CLD1010, Thorlabs GmbH) shown in Figure 1.

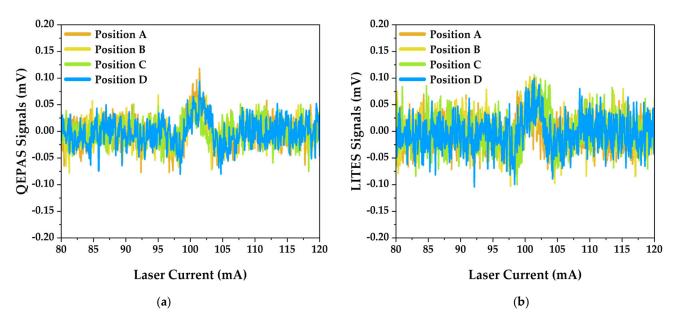
Wavelength Modulation Spectroscopy (WMS) with second-harmonic (2f) detection (i.e., 2f-WMS) was implemented by simultaneously applying the sum of two voltage signals, generated by the Function Generator (AFG31052, Tektronix Inc., Beaverton, OR, USA), to the laser diode controller: a 1 mHz sawtooth wave for scanning the laser tuning range and a sine wave having a frequency of  $f_r/2$  and an amplitude of 85 mVpp for laser injection current modulation. The QTF output signal was amplified using a transimpedance

amplifier stage with a feedback resistance of  $10 \, \mathrm{M}\Omega$  and then the  $f_r$  component was acquired by a lock-in amplifier (7265, PerkinElmer Inc., Shelton, CT, USA). For all measurements, the lock-in integration time constant was set to  $0.1 \, \mathrm{s}$  with a sampling time of  $0.3 \, \mathrm{s}$ . A DAQ card (USB-6002, National Instruments Corp., Austin, TX, USA) allowed data acquisition and storage on a Personal Computer (PC).

### 3. QEPAS and LITES Results

To evaluate the performance of our semi-integrated sensing architecture, both QEPAS and LITES techniques were employed to detect water vapor molecules in a laboratory environment. For both sets of measurements, the optimal position of the QTF with respect to the waveguide output was determined by maximizing the H<sub>2</sub>O QEPAS (and LITES) signal.

Figures 6a and 6b show the QEPAS and LITES spectra, respectively, for indoor  $H_2O$  detection.



**Figure 6.** *2f*-WMS spectra over the laser tuning range at four different QTF positions for (a) QEPAS and (b) LITES measurements. Position A represents the closest distance between the QTF and waveguide output, with subsequent positions (B, C, and D) spaced at 1 mm increments.

For both QEPAS and LITES sets of measurements and for all the QTF positions investigated, a resolved signal corresponding to  $H_2O$  detection was retrieved around 101.41 mA, which corresponds to the targeted  $H_2O$  absorption feature localized at 7181.16 cm<sup>-1</sup> [73]. The resolved signals were obtained with an output laser optical power illuminating the QTF of ~300  $\mu$ W.

The measured signals correspond to a 1.6% absolute humidity of the indoor controlled environment, i.e., with a fixed temperature of 15 °C kept constant by an in-house A/C cooling system and with a gas pressure of 760 Torr. The constant value of water concentration was monitored through a humidity logger (TSP01, Thorlabs GmbH), which recorded relative humidity fluctuations on the order of a few percent during the whole set of measurements.

A noise analysis was performed by calculating the standard deviation of the QEPAS (and LITES) signals in an absorption feature-free region within the laser tuning range (i.e., ranging from a 40 mA to 60 mA laser injection current). In Table 1, the noise levels for both techniques at different positions are reported.

Techniques	QTF Positions				
	A	В	C	D	
QEPAS	0.023 mV	0.019 mV	0.022 mV	0.019 mV	
LITES	0.026  mV	0.027  mV	0.026 mV	0.028  mV	

**Table 1.** Noise levels for both QEPAS and LITES techniques at different QTF positions (A through D).

The slightly lower noise levels observed in QEPAS measurements suggest that the light at the output of the waveguide can pass through the resonator prongs without hitting them, while it is difficult to focus light onto a precise spot of the QTF surface for LITES detection [33] without the help of a focusing lens. Moreover, in QEPAS, the photoacoustic effect occurring in the gas molecules localized between the prongs minimizes direct optical interaction with the QTF surface. Conversely, LITES requires the direct illumination of the QTF surface for thermoelastic effect, making it more susceptible to stray light and thermal noise. However, the laser beam must not hit the gold electrodes since, otherwise, a large, undesirable, non-zero background arises due to the photo-thermal contribution, limiting the sensor detection sensitivity [26].

#### Experimental Data Fitting

As the peak signals for both spectroscopic configurations were barely recognizable above the background noise and to provide meaningful estimations of the signal-to-noise ratio (SNR), a data fitting procedure using the second derivative of a Voigt profile [84] was implemented to properly determine the peak values at the four positions for both QEPAS and LITES. This, in turn, enabled a proper comparison of SNRs.

The Voigt profile,  $V(x;\sigma,\gamma)$ , is expressed as:

$$V(x;\sigma,\gamma) \equiv \int_{-\infty}^{+\infty} G(x';\sigma) L(x-x';\gamma) dx', \tag{1}$$

where x is the shift from the absorption line center, and  $G(x;\sigma)$  is the centered Gaussian distribution:

$$G(x;\sigma) \equiv \frac{e^{-\frac{x^2}{2\sigma^2}}}{\sqrt{2\pi}\sigma},\tag{2}$$

where  $\sigma$  is the Gaussian width parameter (related to Doppler broadening), and  $L(x;\gamma)$  is the centered Lorentzian distribution:

$$L(x;\gamma) \equiv \frac{\gamma}{\pi(\gamma^2 + x^2)},\tag{3}$$

where  $\gamma$  is the Lorentzian width parameter (related to pressure broadening). In 2*f*-WMS, when the laser wavelength is modulated at frequency  $\omega$ , the detected second harmonic signal can be modeled as proportional to the second derivative of the absorption profile [85]:

$$S_{2f} \propto \frac{d^2}{dx^2} [V(x;\sigma,\gamma)].$$
 (4)

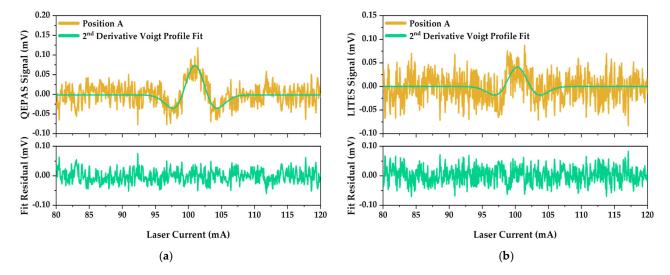
The second derivative Voigt fitting function is implemented in a Python code (Python 3.11) as:

$$V_{2f-FIT}(x) = -a \cdot \frac{d^2}{dx^2} [V(x - x_0, \sigma, \gamma)] + y_0$$
 (5)

where a is the amplitude scaling factor;  $x_0$  is the position of the peak in the scan;  $\sigma$  is the Gaussian width parameter;  $\gamma$  is the Lorentzian width parameter; and  $y_0$  is the baseline

offset. The minus sign in Equation (5) was introduced to account for the detection phase in the lock-in detection.

Figures 7a and 7b show the fitted spectra for representative Position A for both QEPAS and LITES techniques, respectively, along with the corresponding raw signal as a function of the laser current.



**Figure 7.** Second-derivative Voigt profile fitting of the **(a)** QEPAS and **(b)** LITES signals at QTF Position A. Green curves represent optimized Voigt profile fitting the experimental data (orange curves). Lower panels report the fit residual for both techniques.

The fitted signals and the corresponding residuals shown in Figure 7 demonstrate the effectiveness of this fitting procedure.

Peak values at different QTF positions (A through D) were extracted from the fitted signals for both QEPAS and LITES measurements and the resulting SNR values are presented in Table 2.

<b>Table 2.</b> SNRs calculated using peak values extracted from fitted signals for both QEPAS and LITES
techniques at different QTF positions (A through D).

Techniques	QTF Positions				
	Α	В	C	D	
QEPAS	3.2	2.7	1.9	2.9	
LITES	1.6	2.8	2.5	2	

The SNR values presented in Table 2 demonstrate that both QEPAS and LITES techniques achieve comparable detection performances. The highest SNR was obtained with QEPAS at Position A (3.2), while LITES showed its best performance at Position B (2.8). By taking into account these results and considering an  $H_2O$  indoor concentration of 1.6%, a Minimum Detection Limit (MDL) of 0.5% and of 0.6% is achievable with QEPAS and LITES techniques, respectively. Nevertheless, both techniques maintained an effective detection capability across the entire tested distance range, with SNRs consistently above 1.5 at an optical power of ~300  $\mu$ W, thus showing both good mechanical and optical stability. The generally lower SNRs observed in the LITES measurements align with the higher noise levels previously reported in Table 1 and discussed alongside it.

#### 4. Discussion

The experimental results demonstrate the successful coupling between  $Si_3N_4$  waveguide technology and a custom-designed QTF, leveraging both QEPAS and LITES detection

techniques for gas-sensing applications. This semi-integrated architecture represents a significant step toward miniaturized optical gas sensors, particularly for deployment in challenging environments where traditional approaches may be impractical.

The comparable SNR values obtained for both QEPAS (1.9–3.2) and LITES (1.6–2.8) techniques indicate that either method can be effectively implemented with the reported semi-integrated platform.

The slight performance advantage observed in QEPAS measurements, particularly at QTF Position A (SNR = 3.2), is partly due to lower noise levels, thus indicating that it is easier to align the beam at the output of the waveguide between the QTF prongs.

For the LITES case, the small light–molecules interaction volume considered, localized around the polished region of the optical lensed fiber and around the waveguide corecladding interface, limits performance.

However, the consistent detection capability across all positions (up to 3 mm from the waveguide output) demonstrates the robustness of both techniques and provides flexibility in sensor design and implementation.

The integration of the  $\mathrm{Si_3N_4}$  optical waveguide proves to be particularly advantageous, with the S-shaped design effectively preventing scattered light interference while maintaining acceptable optical losses. The measured output laser optical power at the QTF surface of ~300  $\mu$ W, although relatively low, still enabled successful gas detection. This suggests potential for further optimization of the coupling efficiency and/or laser optical power to enhance sensor performance.

#### 5. Conclusions

This work demonstrates a proof of concept for a novel, semi-integrated optical gassensing architecture that combines a  $\rm Si_3N_4$  waveguide with a custom-designed, low-frequency, and T-shaped QTF. The system operates with both QEPAS and LITES using minimal optical power (~300  $\mu W)$  and achieves a comparable performance (SNRs of 1.6–3.2) for water vapor detection in a laboratory environment, confirming its versatility and robustness. The integration of photonic and piezoelectric components represents a significant step toward miniaturized gas sensors.

These low SNRs stem primarily from the limited laser optical power available for sensing. Future developments can increase the available power by optimizing mode matching [78], refining integrated coupling structures [71], or integrating the laser source directly on-chip [76,86]. Furthermore, we plan to implement and test an optical lens that collects the beam at the waveguide output and focuses it onto the detector to lower noise [87]. Future work should also include comprehensive repeatability and long-term stability studies to fully characterize the practical reliability of the sensor for deployment applications. Compatibility with both QEPAS and LITES establishes the foundation for multimodal detection methodologies, which can enhance measurement reliability through complementary sensing and redundant signal validation [40]. The compact nature of this architecture also opens the way to multiplexed sensing via integrating multiple waveguide and laser sources on a single chip [88].

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#### **Abbreviations**

The following abbreviations are used in this manuscript:

2f Second harmonic

CMOS Complementary Metal-Oxide Semiconductor

DAQ Data acquisition fr Resonance frequency

H<sub>2</sub>O Water vapor IR Infrared

LiNTF Lithium Niobate Tuning Fork

LITES Light-Induced Thermoelastic Spectroscopy

MDL Minimum Detection Limit

NIR Near-IR

PC Personal Computer Q Quality factor

QEPAS Quartz-Enhanced Photoacoustic Spectroscopy

QTF Quartz Tuning Fork

SEM Scanning Electron Microscope

Si<sub>3</sub>N<sub>4</sub> Silicon nitride

SiNOI Silicon Nitride-On-Insulator SiO<sub>2</sub> Silicon dioxide/silica SNR Signal-to-noise ratio SWIR Short-Wavelength IR

TDLAS Tunable Diode Laser Absorption Spectroscopy

WMS Wavelength Modulation Spectroscopy

#### References

- 1. Yamazoe, N.; Miura, N. Environmental Gas Sensing. Sens. Actuators B Chem. 1994, 20, 95–102. [CrossRef]
- 2. Sharma, J.N.; Al-Omran, A.; Parvathy, S.S. Role of Nitric Oxide in Inflammatory Diseases. *Inflammopharmacology* **2007**, *15*, 252–259. [CrossRef] [PubMed]
- 3. Yamazoe, N.; Shimanoe, K. New Perspectives of Gas Sensor Technology. Sens. Actuators B Chem. 2009, 138, 100–107. [CrossRef]
- 4. Liu, X.; Cheng, S.; Liu, H.; Hu, S.; Zhang, D.; Ning, H. A Survey on Gas Sensing Technology. *Sensors* **2012**, *12*, 9635–9665. [CrossRef]
- 5. Mac Dowell, N.; Fennell, P.S.; Shah, N.; Maitland, G.C. The Role of CO<sub>2</sub> Capture and Utilization in Mitigating Climate Change. *Nat. Clim. Change* **2017**, *7*, 243–249. [CrossRef]
- 6. Baranwal, J.; Barse, B.; Gatto, G.; Broncova, G.; Kumar, A. Electrochemical Sensors and Their Applications: A Review. *Chemosensors* **2022**, *10*, 363. [CrossRef]

7. Najafi, P.; Ghaemi, A. Chemiresistor Gas Sensors: Design, Challenges, and Strategies: A Comprehensive Review. *Chem. Eng. J.* **2024**, *498*, 154999. [CrossRef]

- 8. Popa, D.; Udrea, F. Towards Integrated Mid-Infrared Gas Sensors. Sensors 2019, 19, 2076. [CrossRef]
- 9. Liu, L.; Wang, Y.; Sun, F.; Dai, Y.; Wang, S.; Bai, Y.; Li, L.; Li, T.; Zhang, T.; Qin, S. "Top-down" and "Bottom-up" Strategies for Wafer-Scaled Miniaturized Gas Sensors Design and Fabrication. *Microsyst. Nanoeng.* **2020**, *6*, 31. [CrossRef]
- 10. El Shamy, R.S.; Swillam, M.A.; ElRayany, M.M.; Sultan, A.; Li, X. Compact Gas Sensor Using Silicon-on-Insulator Loop-Terminated Mach–Zehnder Interferometer. *Photonics* **2021**, *9*, 8. [CrossRef]
- 11. Fan, E.; Liu, H.; Wang, C.; Ma, J.; Guan, B.-O. Compact Optical Fiber Photoacoustic Gas Sensor with Integrated Multi-Pass Cell. *Photoacoustics* **2023**, *32*, 100524. [CrossRef] [PubMed]
- 12. Galli, I.; Bartalini, S.; Ballerini, R.; Barucci, M.; Cancio, P.; De Pas, M.; Giusfredi, G.; Mazzotti, D.; Akikusa, N.; De Natale, P. Spectroscopic Detection of Radiocarbon Dioxide at Parts-per-Quadrillion Sensitivity. *Optica* **2016**, *3*, 385. [CrossRef]
- 13. Itoh, T.; Miwa, T.; Tsuruta, A.; Akamatsu, T.; Izu, N.; Shin, W.; Park, J.; Hida, T.; Eda, T.; Setoguchi, Y. Development of an Exhaled Breath Monitoring System with Semiconductive Gas Sensors, a Gas Condenser Unit, and Gas Chromatograph Columns. *Sensors* **2016**, *16*, 1891. [CrossRef]
- 14. Wang, P.; Chen, W.; Wan, F.; Wang, J.; Hu, J. Cavity-Enhanced Raman Spectroscopy with Optical Feedback Frequency-Locking for Gas Sensing. *Opt. Express* **2019**, *27*, 33312. [CrossRef]
- 15. Boehme, I.; Weimar, U.; Barsan, N. Unraveling the Surface Chemistry of CO Sensing with In2O3 Based Gas Sensors. *Sens. Actuators B Chem.* **2021**, 326, 129004. [CrossRef]
- 16. Cristescu, S.M.; Persijn, S.T.; te Lintel Hekkert, S.; Harren, F.J.M. Laser-Based Systems for Trace Gas Detection in Life Sciences. *Appl. Phys. B* **2008**, 92, 343. [CrossRef]
- 17. Hodgkinson, J.; Tatam, R.P. Optical Gas Sensing: A Review. Meas. Sci. Technol. 2013, 24, 012004. [CrossRef]
- 18. Bogue, R. Detecting Gases with Light: A Review of Optical Gas Sensor Technologies. Sens. Rev. 2015, 35, 133–140. [CrossRef]
- 19. Ma, Y. Review of Recent Advances in QEPAS-Based Trace Gas Sensing. Appl. Sci. 2018, 8, 1822. [CrossRef]
- 20. Yang, T.; Chen, W.; Wang, P. A Review of All-Optical Photoacoustic Spectroscopy as a Gas Sensing Method. *Appl. Spectrosc. Rev.* **2021**, *56*, 143–170. [CrossRef]
- 21. Kosterev, A.A.; Bakhirkin, Y.A.; Curl, R.F.; Tittel, F.K. Quartz-Enhanced Photoacoustic Spectroscopy. *Opt. Lett.* **2002**, 27, 1902. [CrossRef] [PubMed]
- 22. Patimisco, P.; Scamarcio, G.; Tittel, F.; Spagnolo, V. Quartz-Enhanced Photoacoustic Spectroscopy: A Review. *Sensors* **2014**, *14*, 6165–6206. [CrossRef] [PubMed]
- 23. West, G.A.; Barrett, J.J.; Siebert, D.R.; Reddy, K.V. Photoacoustic Spectroscopy. Rev. Sci. Instrum. 1983, 54, 797–817. [CrossRef]
- 24. Friedt, J.-M.; Carry, É. Introduction to the Quartz Tuning Fork. Am. J. Phys. 2007, 75, 415–422. [CrossRef]
- 25. Dong, L.; Kosterev, A.A.; Thomazy, D.; Tittel, F.K. QEPAS Spectrophones: Design, Optimization, and Performance. *Appl. Phys. B* **2010**, *100*, 627–635. [CrossRef]
- 26. Patimisco, P.; Sampaolo, A.; Zheng, H.; Dong, L.; Tittel, F.K.; Spagnolo, V. Quartz–Enhanced Photoacoustic Spectrophones Exploiting Custom Tuning Forks: A Review. *Adv. Phys. X* **2017**, 2, 169–187. [CrossRef]
- 27. Patimisco, P.; Sampaolo, A.; Giglio, M.; dello Russo, S.; Mackowiak, V.; Rossmadl, H.; Cable, A.; Tittel, F.K.; Spagnolo, V. Tuning Forks with Optimized Geometries for Quartz-Enhanced Photoacoustic Spectroscopy. *Opt. Express* **2019**, 27, 1401. [CrossRef]
- 28. Lin, H.; Liu, Y.; Lin, L.; Zhu, W.; Zhou, X.; Zhong, Y.; Giglio, M.; Sampaolo, A.; Patimisco, P.; Tittel, F.K.; et al. Application of Standard and Custom Quartz Tuning Forks for Quartz-Enhanced Photoacoustic Spectroscopy Gas Sensing. *Appl. Spectrosc. Rev.* 2023, *58*, 562–584. [CrossRef]
- Sun, B.; Zifarelli, A.; Wu, H.; Dello Russo, S.; Li, S.; Patimisco, P.; Dong, L.; Spagnolo, V. Mid-Infrared Quartz-Enhanced Photoacoustic Sensor for Ppb-Level CO Detection in a SF<sub>6</sub> Gas Matrix Exploiting a T-Grooved Quartz Tuning Fork. *Anal. Chem.* 2020, 92, 13922–13929. [CrossRef]
- 30. Lin, H.; Zheng, H.; Montano, B.A.Z.; Wu, H.; Giglio, M.; Sampaolo, A.; Patimisco, P.; Zhu, W.; Zhong, Y.; Dong, L.; et al. Ppb-Level Gas Detection Using on-Beam Quartz-Enhanced Photoacoustic Spectroscopy Based on a 28 KHz Tuning Fork. *Photoacoustics* 2022, 25, 100321. [CrossRef]
- 31. Li, S.; Lu, J.; Shang, Z.; Zeng, X.; Yuan, Y.; Wu, H.; Pan, Y.; Sampaolo, A.; Patimisco, P.; Spagnolo, V.; et al. Compact Quartz-Enhanced Photoacoustic Sensor for Ppb-Level Ambient NO<sub>2</sub> Detection by Use of a High-Power Laser Diode and a Grooved Tuning Fork. *Photoacoustics* **2022**, *25*, 100325. [CrossRef] [PubMed]
- 32. Quartz-Enhanced Photoacoustic Sensor for Methane. Available online: https://www.thorlabs.com/newgrouppage9.cfm? objectgroup\_id=16188 (accessed on 12 May 2025).
- 33. Dello Russo, S.; Zifarelli, A.; Patimisco, P.; Sampaolo, A.; Wei, T.; Wu, H.; Dong, L.; Spagnolo, V. Light-Induced Thermo-Elastic Effect in Quartz Tuning Forks Exploited as a Photodetector in Gas Absorption Spectroscopy. *Opt. Express* **2020**, *28*, 19074. [CrossRef] [PubMed]

34. Pan, Y.; Zhao, J.; Lu, P.; Sima, C.; Liu, D. Recent Advances in Light-Induced Thermoelastic Spectroscopy for Gas Sensing: A Review. *Remote Sens.* **2022**, *15*, 69. [CrossRef]

- 35. Sun, J.; Chang, J.; Wang, C.; Shao, J. Tunable Diode Laser Absorption Spectroscopy for Detection of Multi-Component Gas: A Review. *Appl. Spectrosc. Rev.* **2024**, *59*, 1086–1107. [CrossRef]
- 36. Liu, Y.; Qiao, S.; Fang, C.; He, Y.; Sun, H.; Liu, J.; Ma, Y. A Highly Sensitive LITES Sensor Based on a Multi-Pass Cell with Dense Spot Pattern and a Novel Quartz Tuning Fork with Low Frequency. *Opto-Electron. Adv.* **2024**, *7*, 230230. [CrossRef]
- 37. Ma, Y.; He, Y.; Tong, Y.; Yu, X.; Tittel, F.K. Quartz-Tuning-Fork Enhanced Photothermal Spectroscopy for Ultra-High Sensitive Trace Gas Detection. *Opt. Express* **2018**, *26*, 32103. [CrossRef]
- 38. He, Y.; Ma, Y.; Tong, Y.; Yu, X.; Tittel, F.K. Ultra-High Sensitive Light-Induced Thermoelastic Spectroscopy Sensor with a High Q-Factor Quartz Tuning Fork and a Multipass Cell. *Opt. Lett.* **2019**, *44*, 1904. [CrossRef]
- 39. Wei, T.; Zifarelli, A.; Dello Russo, S.; Wu, H.; Menduni, G.; Patimisco, P.; Sampaolo, A.; Spagnolo, V.; Dong, L. High and Flat Spectral Responsivity of Quartz Tuning Fork Used as Infrared Photodetector in Tunable Diode Laser Spectroscopy. *Appl. Phys. Rev.* **2021**, *8*, 041409. [CrossRef]
- 40. Liang, T.; Qiao, S.; Lang, Z.; Ma, Y. Highly Sensitive Trace Gas Detection Based on In-Plane Single-Quartz-Enhanced Dual Spectroscopy. *Sensors* **2022**, 22, 1035. [CrossRef]
- 41. Wu, Q.; Lv, H.; Li, J.; Yang, Z.; Kan, R.; Giglio, M.; Zhu, W.; Zhong, Y.; Sampaolo, A.; Patimisco, P.; et al. Side-Excitation Light-Induced Thermoelastic Spectroscopy. *Opt. Lett.* **2023**, *48*, 562. [CrossRef]
- 42. Qin, L.; Bi, S.; Chen, R.; Zhao, Y.; Shi, J.; Zhang, H.; Wang, Z. Two-Component Gas Sensor of Time-Division Multiplexing Technique Based on QEPAS and LITES. *IEEE Photonics Technol. Lett.* **2024**, *36*, 1085–1088. [CrossRef]
- 43. Ma, Y.; Qiao, S.; Wang, R.; He, Y.; Fang, C.; Liang, T. A Novel Tapered Quartz Tuning Fork-Based Laser Spectroscopy Sensing. *Appl. Phys. Rev.* **2024**, *11*, 041412. [CrossRef]
- 44. Melchiorri, M.; Daldosso, N.; Sbrana, F.; Pavesi, L.; Pucker, G.; Kompocholis, C.; Bellutti, P.; Lui, A. Propagation Losses of Silicon Nitride Waveguides in the Near-Infrared Range. *Appl. Phys. Lett.* **2005**, *86*, 121111. [CrossRef]
- 45. Khan, S.; Chiles, J.; Ma, J.; Fathpour, S. Silicon-on-Nitride Waveguides for Mid- and near-Infrared Integrated Photonics. *Appl. Phys. Lett.* **2013**, *102*, 121104. [CrossRef]
- 46. Muñoz, P.; Micó, G.; Bru, L.; Pastor, D.; Pérez, D.; Doménech, J.; Fernández, J.; Baños, R.; Gargallo, B.; Alemany, R.; et al. Silicon Nitride Photonic Integration Platforms for Visible, Near-Infrared and Mid-Infrared Applications. *Sensors* 2017, 17, 2088. [CrossRef]
- 47. Bucio, T.D.; Lacava, C.; Clementi, M.; Faneca, J.; Skandalos, I.; Baldycheva, A.; Galli, M.; Debnath, K.; Petropoulos, P.; Gardes, F. Silicon Nitride Photonics for the Near-Infrared. *IEEE J. Sel. Top. Quantum Electron.* **2020**, *26*, 1–13. [CrossRef]
- 48. Lin, H.; Luo, Z.; Gu, T.; Kimerling, L.C.; Wada, K.; Agarwal, A.; Hu, J. Mid-Infrared Integrated Photonics on Silicon: A Perspective. *Nanophotonics* **2017**, *7*, 393–420. [CrossRef]
- 49. Su, Y.; Zhang, Y.; Qiu, C.; Guo, X.; Sun, L. Silicon Photonic Platform for Passive Waveguide Devices: Materials, Fabrication, and Applications. *Adv. Mater. Technol.* **2020**, *5*, 1901153. [CrossRef]
- 50. Hughes, S.; Ramunno, L.; Young, J.F.; Sipe, J.E. Extrinsic Optical Scattering Loss in Photonic Crystal Waveguides: Role of Fabrication Disorder and Photon Group Velocity. *Phys. Rev. Lett.* **2005**, *94*, 033903. [CrossRef]
- 51. Li, J.; O'Faolain, L.; Schulz, S.A.; Krauss, T.F. Low Loss Propagation in Slow Light Photonic Crystal Waveguides at Group Indices up to 60. *Photonics Nanostruct.* **2012**, *10*, 589–593. [CrossRef]
- 52. Tombez, L.; Zhang, E.J.; Orcutt, J.S.; Kamlapurkar, S.; Green, W.M.J. Methane Absorption Spectroscopy on a Silicon Photonic Chip. Optica 2017, 4, 1322. [CrossRef]
- 53. Yallew, H.D.; Vlk, M.; Datta, A.; Alberti, S.; Zakoldaev, R.A.; Høvik, J.; Aksnes, A.; Jágerská, J. Sub-Ppm Methane Detection with Mid-Infrared Slot Waveguides. *ACS Photonics* **2023**, *10*, 4282–4289. [CrossRef] [PubMed]
- 54. Luke, K.; Okawachi, Y.; Lamont, M.R.E.; Gaeta, A.L.; Lipson, M. Broadband Mid-Infrared Frequency Comb Generation in a Si\_3N\_4 Microresonator. *Opt. Lett.* **2015**, *40*, 4823. [CrossRef]
- 55. Moss, D.J.; Morandotti, R.; Gaeta, A.L.; Lipson, M. New CMOS-Compatible Platforms Based on Silicon Nitride and Hydex for Nonlinear Optics. *Nat. Photonics* **2013**, *7*, 597–607. [CrossRef]
- 56. Romero-García, S.; Merget, F.; Zhong, F.; Finkelstein, H.; Witzens, J. Silicon Nitride CMOS-Compatible Platform for Integrated Photonics Applications at Visible Wavelengths. *Opt. Express* **2013**, *21*, 14036. [CrossRef]
- 57. Blumenthal, D.J.; Heideman, R.; Geuzebroek, D.; Leinse, A.; Roeloffzen, C. Silicon Nitride in Silicon Photonics. *Proc. IEEE* **2018**, 106, 2209–2231. [CrossRef]
- 58. Sharma, T.; Wang, J.; Kaushik, B.K.; Cheng, Z.; Kumar, R.; Wei, Z.; Li, X. Review of Recent Progress on Silicon Nitride-Based Photonic Integrated Circuits. *IEEE Access* **2020**, *8*, 195436–195446. [CrossRef]
- 59. Xiang, C.; Jin, W.; Bowers, J.E. Silicon Nitride Passive and Active Photonic Integrated Circuits: Trends and Prospects. *Photonics Res.* **2022**, *10*, A82. [CrossRef]

60. Debrégeas-Sillard, H.; Kazmierski, C. Challenges and Advances of Photonic Integrated Circuits. *Comptes Rendus Phys.* **2008**, *9*, 1055–1066. [CrossRef]

- 61. Maire, G.; Vivien, L.; Sattler, G.; Kazmierczak, A.; Sanchez, B.; Gylfason, K.B.; Griol, A.; Marris-Morini, D.; Cassan, E.; Giannone, D.; et al. High Efficiency Silicon Nitride Surface Grating Couplers. *Opt. Express* **2008**, *16*, 328. [CrossRef]
- 62. Hong, J.; Spring, A.M.; Qiu, F.; Yokoyama, S. A High Efficiency Silicon Nitride Waveguide Grating Coupler with a Multilayer Bottom Reflector. *Sci. Rep.* **2019**, *9*, 12988. [CrossRef] [PubMed]
- 63. Yoo, K.M.; Midkiff, J.; Rostamian, A.; Chung, C.; Dalir, H.; Chen, R.T. InGaAs Membrane Waveguide: A Promising Platform for Monolithic Integrated Mid-Infrared Optical Gas Sensor. *ACS Sens.* 2020, *5*, 861–869. [CrossRef] [PubMed]
- 64. Song, Y.; Li, B.; Zhang, H.; Li, M.; Li, Q.; He, J.-J. Silicon Waveguide Sensors for Carbon Dioxide Gas Sensing in the Mid-Infrared Region. *Photonics* **2023**, *10*, 120. [CrossRef]
- 65. Yan, Y.; Feng, H.; Wang, C.; Ren, W. On-Chip Photothermal Gas Sensor Based on a Lithium Niobate Rib Waveguide. *Sens. Actuators B Chem.* **2024**, 405, 135392. [CrossRef]
- 66. Cantatore, A.F.P.; Menduni, G.; Zifarelli, A.; Patimisco, P.; Gonzalez, M.; Seren, H.R.; Spagnolo, V.; Sampaolo, A. Lithium Niobate—Enhanced Photoacoustic Spectroscopy. *Photoacoustics* **2024**, *35*, 100577. [CrossRef]
- 67. Ma, Y. Recent Advances in QEPAS and QEPTS Based Trace Gas Sensing: A Review. Front. Phys. 2020, 8, 268. [CrossRef]
- 68. Zifarelli, A.; De Palo, R.; Venck, S.; Joulain, F.; Cozic, S.; Weih, R.; Sampaolo, A.; Patimisco, P.; Spagnolo, V. All-Fiber-Coupled Mid-Infrared Quartz-Enhanced Photoacoustic Sensors. *Opt. Laser Technol.* **2024**, *176*, 110926. [CrossRef]
- 69. Yang, X.; Xiao, Y.; Ma, Y.; He, Y.; Tittel, F. A Miniaturized QEPAS Trace Gas Sensor with a 3D-Printed Acoustic Detection Module. Sensors 2017, 17, 1750. [CrossRef]
- 70. Passaro, V.; Tullio, C.; Troia, B.; Notte, M.; Giannoccaro, G.; Leonardis, F. Recent Advances in Integrated Photonic Sensors. *Sensors* **2012**, *12*, 15558–15598. [CrossRef]
- 71. De Carlo, M.; Menduni, G.; Sampaolo, A.; De Leonardis, F.; Spagnolo, V.; Passaro, V.M.N. Modeling and Design of a Semi-Integrated QEPAS Sensor. *J. Light. Technol.* **2021**, *39*, 646–653. [CrossRef]
- 72. Marcuse, D. Length Optimization of an S-Shaped Transition between Offset Optical Waveguides. *Appl. Opt.* **1978**, *17*, 763. [CrossRef] [PubMed]
- 73. Gordon, I.E.; Rothman, L.S.; Hargreaves, R.J.; Hashemi, R.; Karlovets, E.V.; Skinner, F.M.; Conway, E.K.; Hill, C.; Kochanov, R.V.; Tan, Y.; et al. The HITRAN2020 Molecular Spectroscopic Database. *J. Quant. Spectrosc. Radiat. Transf.* **2022**, 277, 107949. [CrossRef]
- 74. Pajares, G. Overview and Current Status of Remote Sensing Applications Based on Unmanned Aerial Vehicles (UAVs). *Photogramm. Eng. Remote Sens.* **2015**, *81*, 281–330. [CrossRef]
- 75. Duangsuwan, S.; Jamjareekulgarn, P. Development of Drone Real-Time Air Pollution Monitoring for Mobile Smart Sensing in Areas with Poor Accessibility. *Sens. Mater.* **2020**, 32, 511–520. [CrossRef]
- 76. Remis, A.; Monge-Bartolome, L.; Paparella, M.; Gilbert, A.; Boissier, G.; Grande, M.; Blake, A.; O'Faolain, L.; Cerutti, L.; Rodriguez, J.-B.; et al. Unlocking the Monolithic Integration Scenario: Optical Coupling between GaSb Diode Lasers Epitaxially Grown on Patterned Si Substrates and Passive SiN Waveguides. *Light Sci. Appl.* 2023, 12, 150. [CrossRef]
- 77. Ji, X.; Okawachi, Y.; Gil-Molina, A.; Corato-Zanarella, M.; Roberts, S.; Gaeta, A.L.; Lipson, M. Ultra-Low-Loss Silicon Nitride Photonics Based on Deposited Films Compatible with Foundries. *Laser Photonics Rev.* **2023**, *17*, 202200544. [CrossRef]
- 78. Thottoli, A.; Vorobev, A.S.; Biagi, G.; Iadanza, S.; Giglio, M.; Magno, G.; Grande, M.; O'Faolain, L. Compact Angled Multimode Interference Duplexers for Multi-Gas Sensing Applications. *Opt. Express* **2024**, *32*, 3451. [CrossRef]
- 79. Fang, Q.; Liow, T.-Y.; Song, J.F.; Tan, C.W.; Yu, M.B.; Lo, G.Q.; Kwong, D.-L. Suspended Optical Fiber-to-Waveguide Mode Size Converter for Silicon Photonics. *Opt. Express* **2010**, *18*, 7763–7769. [CrossRef]
- 80. Almeida, V.R.; Panepucci, R.R.; Lipson, M. Nanotaper for Compact Mode Conversion. Opt. Lett. 2003, 28, 1302. [CrossRef]
- 81. McNab, S.; Moll, N.; Vlasov, Y. Ultra-Low Loss Photonic Integrated Circuit with Membrane-Type Photonic Crystal Waveguides. *Opt. Express* **2003**, *11*, 2927. [CrossRef]
- 82. Olivieri, M.; Zifarelli, A.; Menduni, G.; Di Gioia, M.; Marzocca, C.; Passaro, V.M.N.; Sampaolo, A.; Giglio, M.; Spagnolo, V.; Patimisco, P. Influence of Air Pressure on the Resonance Properties of a T-Shaped Quartz Tuning Fork Coupled with Resonator Tubes. *Appl. Sci.* **2021**, *11*, 7974. [CrossRef]
- 83. Zheng, H.; Lin, H.; Dong, L.; Liu, Y.; Patimisco, P.; Zweck, J.; Mozumder, A.; Sampaolo, A.; Spagnolo, V.; Huang, B.; et al. Influence of Tuning Fork Resonance Properties on Quartz-Enhanced Photoacoustic Spectroscopy Performance. *Sensors* **2019**, *19*, 3825. [CrossRef] [PubMed]
- 84. Reid, J.; Labrie, D. Second-Harmonic Detection with Tunable Diode Lasers? Comparison of Experiment and Theory. *Appl. Phys. B Photophysics Laser Chem.* **1981**, *26*, 203–210. [CrossRef]
- 85. Xu, L.; Li, J.; Liu, N.; Zhou, S. Quartz Crystal Tuning Fork Based 2f/1f Wavelength Modulation Spectroscopy. *Spectrochim. Acta A Mol. Biomol. Spectrosc.* **2022**, 267, 120608. [CrossRef]
- 86. Zhou, Z.; Ou, X.; Fang, Y.; Alkhazraji, E.; Xu, R.; Wan, Y.; Bowers, J.E. Prospects and Applications of On-Chip Lasers. *eLight* **2023**, 3, 1. [CrossRef]

87. Dietrich, P.-I.; Blaicher, M.; Reuter, I.; Billah, M.; Hoose, T.; Hofmann, A.; Caer, C.; Dangel, R.; Offrein, B.; Troppenz, U.; et al. In Situ 3D Nanoprinting of Free-Form Coupling Elements for Hybrid Photonic Integration. *Nat. Photonics* **2018**, *12*, 241–247. [CrossRef]

88. Dai, D. Silicon Nanophotonic Integrated Devices for On-Chip Multiplexing and Switching. *J. Light. Technol.* **2017**, *35*, 572–587. [CrossRef]

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